

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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## Title of Invention

DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE  
FABRICATION

Application Number :

Confirmation Number:

First Named Applicant: June Cline

Attorney Docket Number: BUR920040122US1

Art Unit:

Examiner:

Search string: ( 6676800 or 6318384 or 6235214 or 6127278 or 6020269 or 5807789 ).pn

## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6676800	2004-01-13	Festa et al			
	2	6318384	2001-11-20	Khan et al			
	3	6235214	2001-05-22	Deshmukh et al			
	4	6127278	2000-10-03	Wang et al			
	5	6020269	2000-02-01	Wang et al			
	6	5807789	1998-09-15	Chen et al			

## Signature

Examiner Name	Date